

Typical Applications

The HMC949 is ideal for:

- Point-to-Point Radios
- Point-to-Multi-Point Radios
- VSAT & SATCOM
- Military & Space

Features

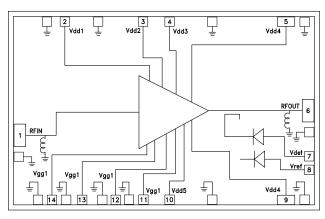
Saturated Output Power: +35.5 dBm @ 26% PAE

High Output IP3: +42 dBm

High Gain: 31 dB

DC Supply: +7V @ 1200 mA No External Matching Required Die Size: 2.71 x 1.73 x 0.1 mm

Functional Diagram



General Description

The HMC949 is a 4 stage GaAs pHEMT MMIC 2 Watt Power Amplifier with an integrated temperature compensated on-chip power detector which operates between 12 and 16 GHz. The HMC949 provides 31 dB of gain, +35.5 dBm of saturated output power, and 26% PAE from a +7V supply. The HMC949 exhibits excellent linearity and is optimized for high capacity digital microwave radio. It is also ideal for 13.75 to 14.5 GHz Ku Band VSAT transmitters as well as SATCOM applications. All data is taken with the chip in a 50 Ohm test fixture connected via (2) 0.025 mm (1 mil) diameter wire bonds of 0.31 mm (12 mil) length.

Electrical Specifications

 $T_A = +25^{\circ} \text{ C}$, Vdd = Vdd1 = Vdd2 = Vdd3 = Vdd4 = Vdd5 = +7V, Idd = 1200 mA [1]

Parameter	Min.	Тур.	Max.	Units
Frequency Range		12 - 16		GHz
Gain	28	31		dB
Gain Variation Over Temperature		0.05		dB/ °C
Input Return Loss		10		dB
Output Return Loss		17		dB
Output Power for 1 dB Compression (P1dB)	32.5	34.5		dBm
Saturated Output Power (Psat)		35.5		dBm
Output Third Order Intercept (IP3)[2]		42		dBm
Total Supply Current (Idd)		1200		mA

^[1] Adjust Vgg between -2 to 0V to achieve Idd = 1200mA typical.

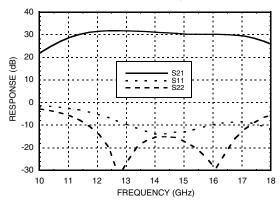
^[2] Measurement taken at +7V @ 1200mA, Pout / Tone = +22 dBm



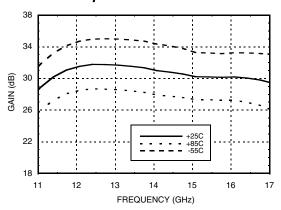
GaAs pHEMT MMIC 2 WATT POWER AMPLIFIER

WITH POWER DETECTOR, 12 - 16 GHz

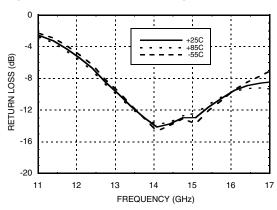
Broadband Gain & Return Loss vs. Frequency



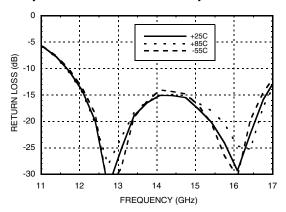
Gain vs. Temperature



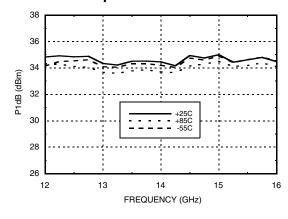
Input Return Loss vs. Temperature



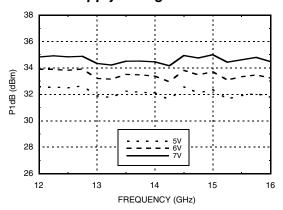
Output Return Loss vs. Temperature



P1dB vs. Temperature



P1dB vs. Supply Voltage

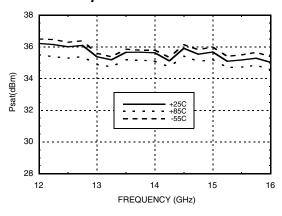




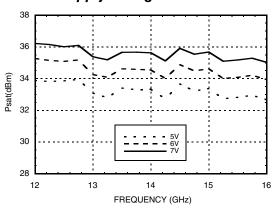
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GaAs pHEMT MMIC 2 WATT POWER AMPLIFIER WITH POWER DETECTOR, 12 - 16 GHz

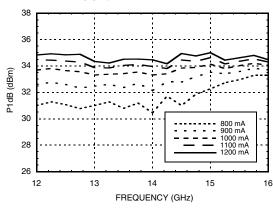
Psat vs. Temperature



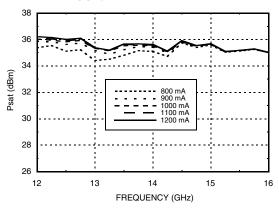
Psat vs. Supply Voltage



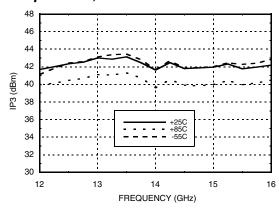
P1dB vs. Supply Current (Idd)



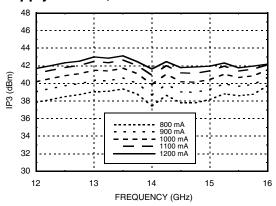
Psat vs. Supply Current (Idd)



Output IP3 vs. Temperature, Pout/Tone = +22 dBm



Output IP3 vs.
Supply Current, Pout/Tone = +22 dBm

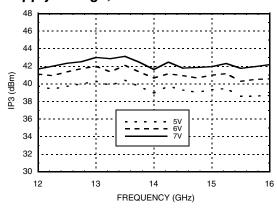




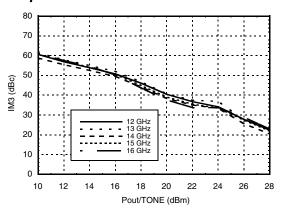
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GaAs pHEMT MMIC 2 WATT POWER AMPLIFIER WITH POWER DETECTOR, 12 - 16 GHz

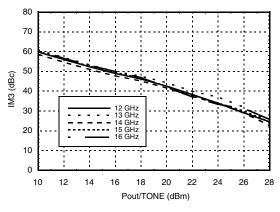
Output IP3 vs.
Supply Voltage, Pout/Tone = +22 dBm



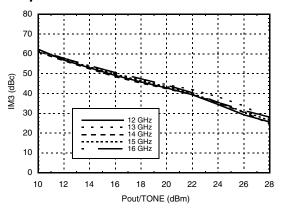
Output IM3 @ Vdd = +5V



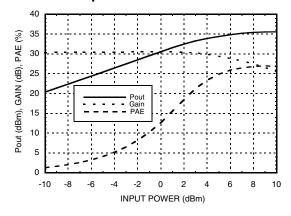
Output IM3 @ Vdd = +6V



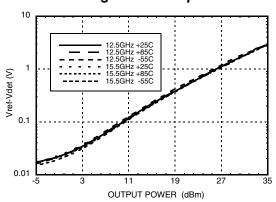
Output IM3 @ Vdd = +7V



Power Compression @ 14 GHz

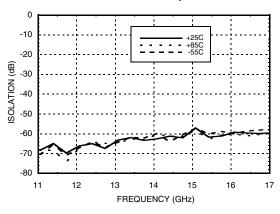


Detector Voltage Over Temperature

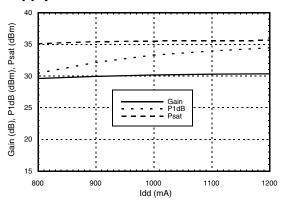




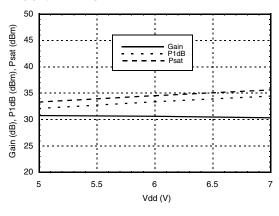
Reverse isolation vs. Temperature



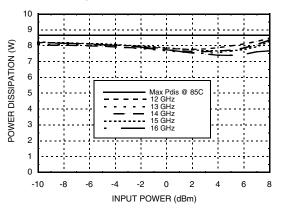
Gain & Power vs. Supply Current @ 14 GHz



Gain & Power vs. Supply Voltage @ 14 GHz



Power Dissipation



Absolute Maximum Ratings

Drain Bias Voltage (Vdd)	+8V	
RF Input Power (RFIN)	+24 dBm	
Channel Temperature	150 °C	
Continuous Pdiss (T= 85 °C) (derate 133 mW/°C above 85 °C)	8.6 W	
Thermal Resistance (channel to die bottom)	7.5 °C/W	
Storage Temperature	-65 to +150 °C	
Operating Temperature	-55 to +85 °C	

Typical Supply Current vs. Vdd

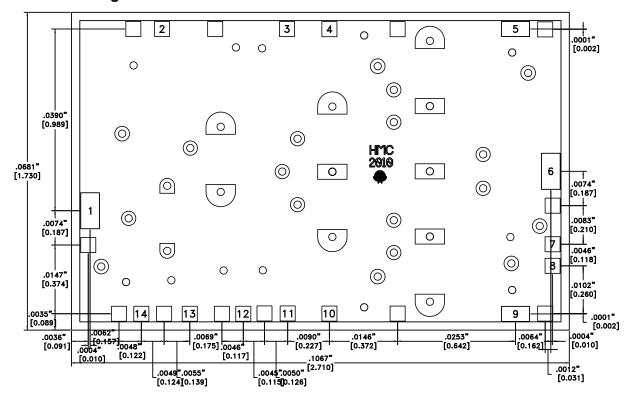
Vdd (V)	Idd (mA)
+5.0	1200
+6.0	1200
+7.0	1200

Note: Amplifier will operate over full voltage ranges shown above Vgg adjusted to achieve Idd = 1200 mA





Outline Drawing



Die Packaging Information [1]

Standard	Alternate
GP-1 (Gel Pack)	[2]

^[1] Refer to the "Packaging Information" section for die packaging dimensions.

NOTES:

- 1. ALL DIMENSIONS ARE IN INCHES [MM]
- 2. DIE THICKNESS IS .004"
- 3. TYPICAL BOND PAD IS .004" SQUARE
- 4. BACKSIDE METALLIZATION: GOLD
- 5. BOND PAD METALLIZATION: GOLD
- 6. BACKSIDE METAL IS GROUND.
- 7. CONNECTION NOT REQUIRED FOR UNLABELED BOND PADS.
- 8. OVERALL DIE SIZE ± .002

Pad Descriptions

Pad Number	Function	Description	Interface Schematic
1	RFIN	This pad is DC coupled and matched to 50 Ohms over the operating frequency range.	RFIN O
2 - 5	Vdd1, Vdd2, Vdd3, Vdd4	Drain bias voltage for the amplifier. External bypass capacitors of 100 pF are required for each pad, followed by common 0.1 µF capacitors.	∨Vdd1−5 -
9 - 10	Vdd4, Vdd5	common our productions.	<u></u>
6	RFOUT	This pad is DC coupled and matched to 50 Ohms.	─────────────────────────────────────

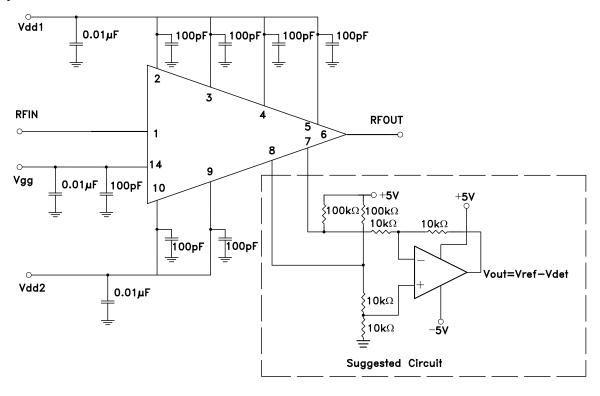
^[2] For alternate packaging information contact Hittite Microwave Corporation.



Pad Descriptions (continued)

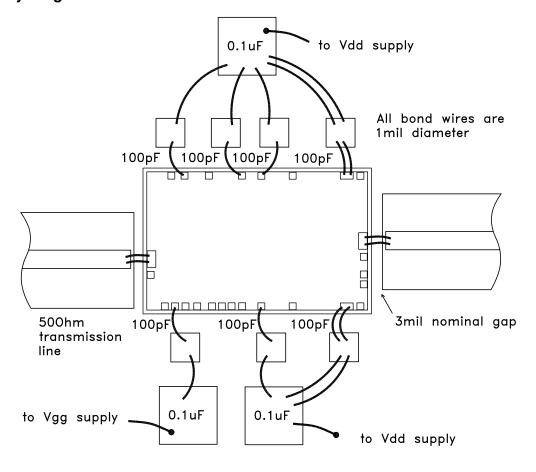
Pad Number	Function	Description	Interface Schematic
7	Vdet	DC voltage representing RF output power rectified by diode which is biased through an external resistor.	
8	Vref	DC voltage of diode biased through external resistor, used for temperature compensation of Vdet.	
11 - 14	Vgg1	Gate control for amplifier. External bypass capacitors of 100 pF and 0.1 μF are required. These pads are connected on chip	Vgg10
Die Bottom	GND	Die bottom must be connected to RF/DC ground.	GND =

Application Circuit





Assembly Diagram





Mounting & Bonding Techniques for Millimeterwave GaAs MMICs

The die should be attached directly to the ground plane eutectically or with conductive epoxy (see HMC general Handling, Mounting, Bonding Note).

50 Ohm Microstrip transmission lines on 0.127mm (5 mil) thick alumina thin film substrates are recommended for bringing RF to and from the chip (Figure 1). If 0.254mm (10 mil) thick alumina thin film substrates must be used, the die should be raised 0.150mm (6 mils) so that the surface of the die is coplanar with the surface of the substrate. One way to accomplish this is to attach the 0.102mm (4 mil) thick die to a 0.150mm (6 mil) thick molybdenum heat spreader (moly-tab) which is then attached to the ground plane (Figure 2).

Microstrip substrates should be located as close to the die as possible in order to minimize bond wire length. Typical die-to-substrate spacing is 0.076mm to 0.152 mm (3 to 6 mils).

Handling Precautions

Follow these precautions to avoid permanent damage.

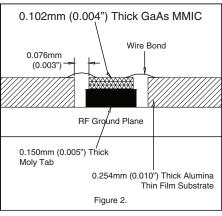
Storage: All bare die are placed in either Waffle or Gel based ESD protective containers, and then sealed in an ESD protective bag for shipment. Once the sealed ESD protective bag has been opened, all die should be stored in a dry nitrogen environment.

Cleanliness: Handle the chips in a clean environment. DO NOT attempt to clean the chip using liquid cleaning systems.

Static Sensitivity: Follow ESD precautions to protect against > ± 250V ESD strikes.

Transients: Suppress instrument and bias supply transients while bias is applied. Use shielded signal and bias cables to minimize inductive pickup.

0.102mm (0.004") Thick GaAs MMIC Wire Bond 0.076mm (0.003")RF Ground Plane 0.127mm (0.005") Thick Alumina Thin Film Substrate Figure 1.



General Handling: Handle the chip along the edges with a vacuum collet or with a sharp pair of bent tweezers. The surface of the chip may have fragile air bridges and should not be touched with vacuum collet, tweezers, or fingers.

Mounting

The chip is back-metallized and can be die mounted with AuSn eutectic preforms or with electrically conductive epoxy. The mounting surface should be clean and flat.

Eutectic Die Attach: A 80/20 gold tin preform is recommended with a work surface temperature of 255 °C and a tool temperature of 265 °C. When hot 90/10 nitrogen/hydrogen gas is applied, tool tip temperature should be 290 °C. DO NOT expose the chip to a temperature greater than 320 °C for more than 20 seconds. No more than 3 seconds of scrubbing should be required for attachment.

Epoxy Die Attach: Apply a minimum amount of epoxy to the mounting surface so that a thin epoxy fillet is observed around the perimeter of the chip once it is placed into position. Cure epoxy per the manufacturer's schedule.

Wire Bonding

Ball or wedge bond with 0.025mm (1 mil) diameter pure gold wire. Thermosonic wirebonding with a nominal stage temperature of 150 °C and a ball bonding force of 40 to 50 grams or wedge bonding force of 18 to 22 grams is recommended. Use the minimum level of ultrasonic energy to achieve reliable wirebonds. Wirebonds should be started on the chip and terminated on the package or substrate. All bonds should be as short as possible <0.31mm (12 mils).





Notes: